## **CERTIFICATE OF CORRECTION**

PATENT NO.

: 6,847,105 B2

Page 1 of 5

APPLICATION NO.: 09/960089

**DATED** 

: January 25, 2005

INVENTOR(S)

: Michel Koopmans

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

## On the title page, section (57): ABSTRACT, 11<sup>th</sup> line

change "a bond pad on top semiconductor" to

--a bond pad on the top semiconductor--

## In the drawings:

In FIG. 2

insert reference numeral --74-- and associated

lead line at top central portion of drawing

In FIG. 6 In FIG. 7

In FIG. 8

In FIG. 10

In FIG. 11

insert -- (PRIOR ART)-- right below "Fig. 6"

insert -- (PRIOR ART) -- right below "Fig. 7"

and insert reference numeral --724-- and

associated lead line at the bottom left portion

between reference numerals "760" and "728"

insert -- (PRIOR ART) -- right below "Fig. 8"

change reference numeral "976" to --974'-insert reference numeral -- 1030-- and

associated lead line at bottom left portion of

drawing

In FIG. 14 insert reference numeral --930" -- and

associated lead line at bottom right portion of

drawing

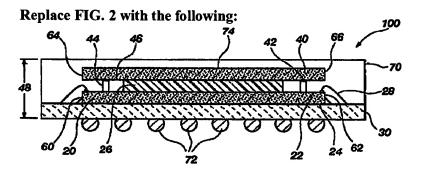


Fig. 2

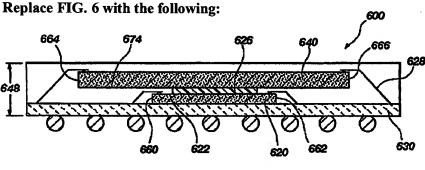


Fig. 6 (PRIŎŔ ART)

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: Michel Koopmans

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

## Replace FIG. 7 with the following:

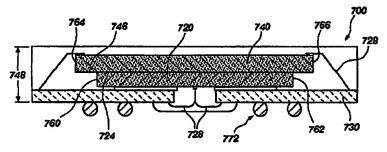
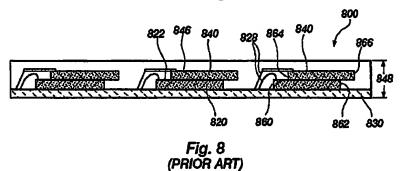


Fig. 7 (PRIOR ART)

## Replace FIG. 8 with the following:



## Replace FIG. 10 with the following:

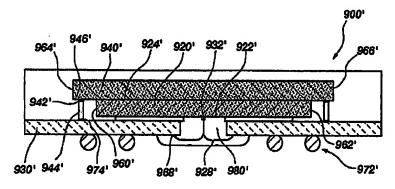


Fig. 10

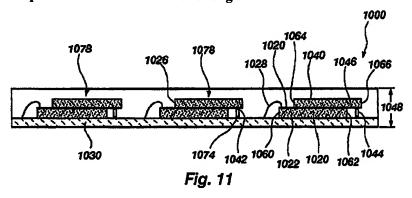
## **CERTIFICATE OF CORRECTION**

PATENT NO. : 6,847,105 B2 Page 3 of 5

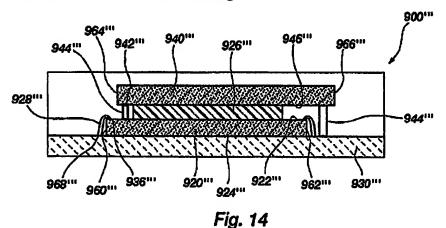
APPLICATION NO.: 09/960089
DATED: January 25, 2005
INVENTOR(S): Michel Koopmans

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

#### Replace FIG. 11 with the following:



#### Replace FIG. 14 with the following:



#### In the Specification:

COLUMN 1, LINES 49-51, after "circuit board." delete the remainder of

the paragraph (duplicate sentence): "A variation of the pin-in-recess PGA, wherein the

loops of the J's are soldered to pads on the

surface of the circuit board."

COLUMN 2, LINE 50, change "chip on board" to --chip-on-board--change "packaged die" to --packaged dice--

COLUMN 3, LINE 50, change "stacked die" to --stacked dice-change "corresponding redistribution" to

--corresponding first redistribution--

## **CERTIFICATE OF CORRECTION**

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: 6,847,105 B2

Page 4 of 5

**APPLICATION NO. : 09/960089** 

DATED

: January 25, 2005

INVENTOR(S) : Michel Koopmans

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

## In the Specification: (cont'd)

COLUMN 4, LINE 20,	change "distance that bond" todistance so that bond
COLUMN 4, LINE 21,	change "above an" toabove the
COLUMN 4, LINES 28-29,	change "bond pad on substrate." tobond pad on the substrate
COLUMN 5, LINE 8,	change "that include" tothat includes
COLUMN 5, LINE 31,	change "chip type" tochip-type
COLUMN 5, LINE 48,	change "additional semiconductor die" toadditional semiconductor dice
COLUMN 6, LINE 40,	change "having bond pads 430" tohaving first redistribution bond pads 430
COLUMN 6, LINE 42,	change "to the bond" toto the first redistribution bond
COLUMN 6, LINE 50,	change "connected, bond" toconnected, first
00 DOM 10 0, DA 12 00,	redistribution bond
COLUMN 7, LINE 15,	change "semiconductor die 20. (FIG. 2)." to
	semiconductor die 20 (FIG. 2)
COLUMN 7, LINE 24,	change "maybe" tomay be
COLUMN 8, LINE 22,	change "At least one peripheral" toAt least one of the peripheral
COLUMN 8, LINE 24,	change "least one edge of the peripheral edges"
	toleast one of the peripheral edges
COLUMN 8, LINE 28,	change "maybe" tomay be
COLUMN 9, LINE 16,	change "(e.g; solder," to(e.g., solder,
COLUMN 9, LINE 19,	change "semiconductoor die" to
	semiconductor die
COLUMN 9, LINE 23,	change "the second die 920"" tothe second
	semiconductor die 920"
COLUMN 9, LINE 28,	change "962", 960"" to966", 964"
COLUMN 9, LINE 56,	change "conductor filled epoxy," to
	conductor-filled epoxy,
COLUMN 10, LINE 5,	change "of a bottom semiconductor" toof the
COLUMN 10, LINE 38,	top semiconductor change "peripheral edge 1064, 1066" to
COLOMIT 10, ENTE 58,	peripheral edges 1064, 1066
COLUMN 10, LINE 50,	change "maybe" tomay be
COLUMN 10, LINE 57,	change "conductor filled epoxy," to
,	conductor-filled epoxy,
COLUMN 10, LINE 63,	change "maybe" tomay be

# UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO. : 6,847,105 B2 Page 5 of 5

APPLICATION NO.: 09/960089
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INVENTOR(S): Michel Koopmans

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

#### In the claims:

CLAIM 12, COLUMN 12, LINE 32-33, change "bond pad is electrically" to --bond pad

of said at least one redistribution bond pad

circuit is electrically--

CLAIM 24, COLUMN 13, LINE 34, change "semiconductor die are all electrically"

to --semiconductor die are electrically--

Signed and Sealed this

Twenty-fourth Day of July, 2007

JON W. DUDAS
Director of the United States Patent and Trademark Office